



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Woo Sik Yoo
Assignee: WaferMasters, Inc.
Title: Method for H2 Recycling In Semiconductor Processing System
Serial No.: 09/828,518 Filing Date: April 6, 2001
Examiner: Olivia T. Luk Group Art Unit: 2812
Docket No.: M-8608US

Irvine, California
August 21, 2002

BOX AMENDMENT
COMMISSIONER FOR PATENTS
Washington, D. C. 20231

CHANGE OF CORRESPONDENCE ADDRESS

Dear Sir:

Please direct all correspondence in the above-identified application and with respect to any patent that issues on this application to the undersigned at this address:

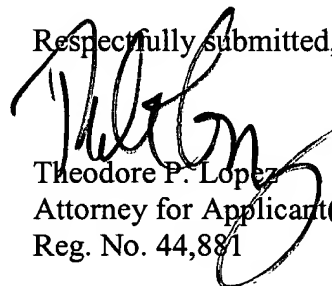
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Express Mail Label No.:

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Respectfully submitted,


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